

Aim:

Fast automated inspection of large-area objects with micro- and nano-scale structures

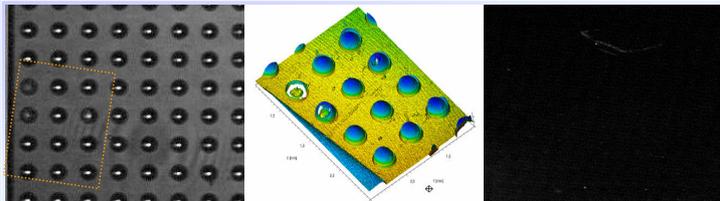
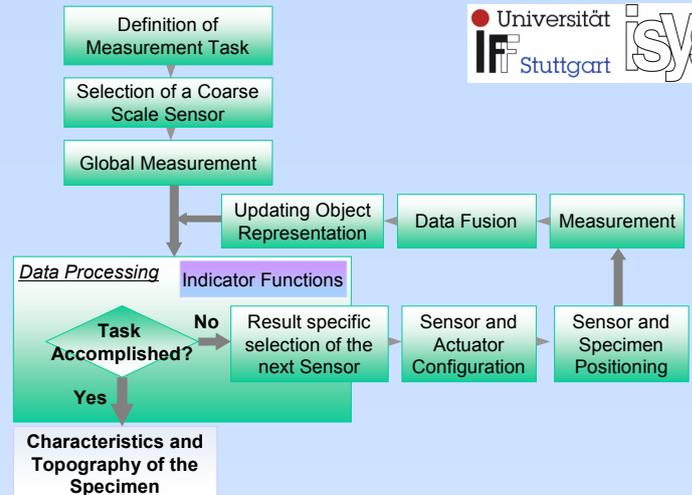
Problem:

Limited sensor resolution-to-field ($\delta A = 10^{-4}$)

Solution:

Automated Multiscale Measurement Strategy

- Multiscale sensor concept
- High resolution is only utilised where required
- Indicators, which are deviations from the expected measurement results, are used to enable the multisensor concept. Thus task specific selection of indicator functions is required



a) b) c)

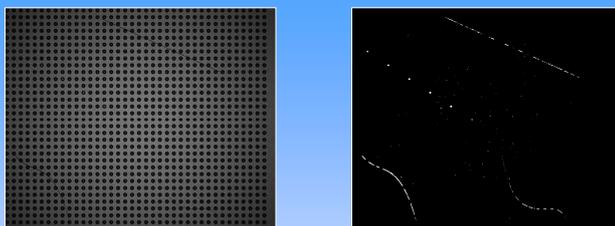
Data from sensors measuring point spread function (a), topography (b) and stray light (c)

Indicator Functions	Remarks
<i>Fourier Self Filtering</i>	high periodic structures video microscopy level
<i>Correlation Based Method</i>	need of enough resolution good at video microscopy level best at confocal microscopy level
<i>Fourier Descriptors Based Method</i>	best at confocal microscopy level
<i>Texture Based Method</i>	lower sensitivity does not depend on illumination
<i>Contrast Based Method under Incident light</i>	only for scratch and particle pollution detection under incident illumination

Table 1: Several indicator detection algorithms for microlens arrays were used on the data from two different sensors: a video microscope and a confocal microscope

Example Indicator Detection Functions:

Fourier Self Filtering



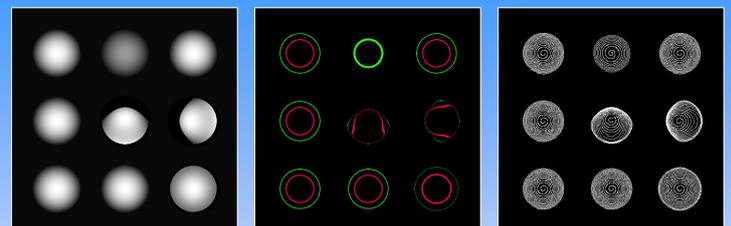
resulting image

Fourier self filtering is a process of removing all the periodic elements from the input image.

This can be done by masking out all the peaks in the Fourier domain of the input image and transforming back to spatial domain.

As it can be seen from the above result, the only elements that will be left are non-periodic elements, which are the indicators in our case.

Fourier Descriptor Based Method



Fourier Descriptors (FD) can be used to describe shapes based on their contours.

$FD = FFT(Z)$; $Z_i = X_i + iY_i$ $i=1..n$ (number of points on the contour), where X_i and Y_i correspond to the position of the points on the contour in pixels (x,y).

Two methods: 1. Ring Method and 2. Spiral Method are presented in the above shown images to detect indicators on simulated confocal sensor data.

- Fourier descriptors are calculated for each Spiral / Ring
- Results are compared with the corresponding Spiral / Ring of an ideal lens to estimate the correctness of the lens.
- Fourier descriptors are scale and rotation invariant